



**ELECTRONIC COPY**

LG802634692  
Report verification at igi.org



May 20, 2026  
IGI Report Number **LG802634692**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **9.33 X 6.39 X 4.32 MM**

**GRADING RESULTS**

Carat Weight **2.56 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

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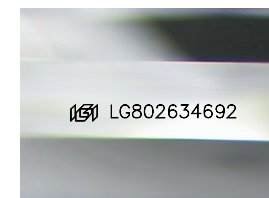
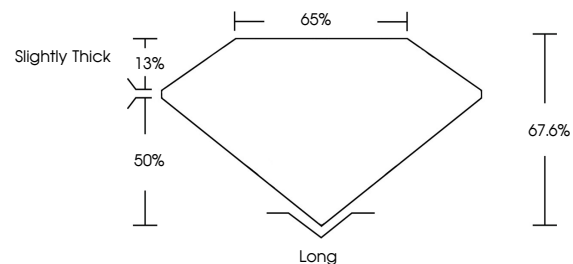
Carat Weight **2.56 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG802634692**

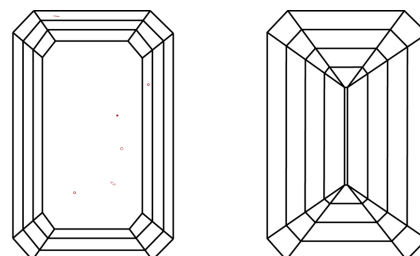
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

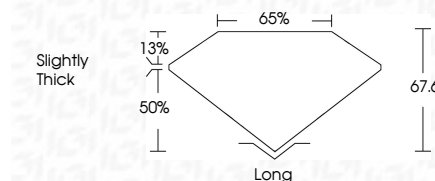
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



May 20, 2026  
IGI Report No. **LG802634692**  
**EMERALD CUT**  
9.33 X 6.39 X 4.32 MM  
Carat Weight **2.56 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **67.6%**  
Table **65%**  
Girdle **Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG802634692**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa